



**ELECTRONIC COPY**

LG750588424  
Report verification at igi.org



December 11, 2025

IGI Report Number **LG750588424**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL MODIFIED BRILLIANT**

Measurements **10.32 X 7.47 X 4.80 MM**

**GRADING RESULTS**

Carat Weight **2.86 CARATS**

Color Grade **D**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

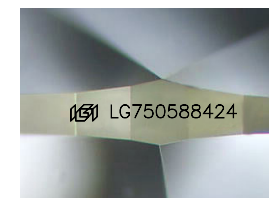
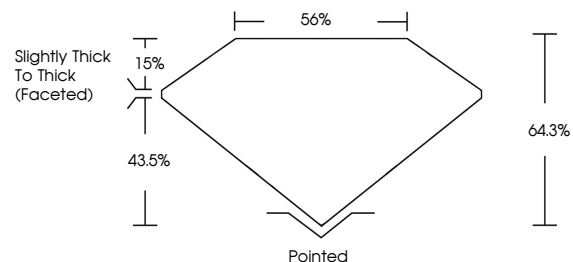
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG750588424**

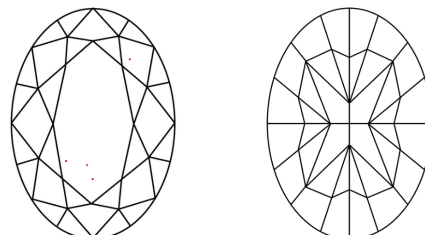
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

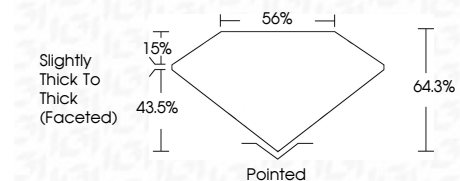
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

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OVAL MODIFIED BRILLIANT  
10.32 X 7.47 X 4.80 MM  
2.86 CARATS  
D  
Carat Weight  
Color Grade  
Clarity Grade  
Depth  
Table  
Girdle  
Slightly Thick To Thick (Faceted)  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG750588424  
Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

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